

Form PTO-1449 U.S. Dept. of Commerce Patent & Trademark Office	Atty. Docket: 00-GR1-408	Serial No.: 10/044,286
List of Documents Cited by Applicant (Use several sheets if necessary)	Applicant: Olivier MENUT et al.	
	Filing Date: January 11, 2002	Group: 2814

U.S. PATENT DOCUMENTS

FOREIGN PATENT DOCUMENTS

		Document Number	Date	Country	Class	Sub-class	Transl'n Yes/No
<i>PF</i>	AA2	WO99/48152	September 23, 1999	PCT			Yes

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

	AA3	"One-Device CMOS Dram Cell with Buried Poly Trench and Drain Reach Through," IBM Technical Disclosure Bulletin, pp. 451-452, Vol. 30, No. 11, April 1988.
	AA4	"Vertical Conducting Connection to a Poly-Si Trench In Si," IBM Technical Disclosure Bulletin, pp. 310-312, Vol. 31, No. 12, May 1989.
	AA5	Preliminary Search Report dated October 19, 2001 for French Patent Application No. 0100420.

Examiner:

Date Considered:

8/15/05

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.